



648.42568VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MIYA et al

Serial No.: 10/779,742

Filed: February 18, 2004

For: Plasma Processing Apparatus And Plasma
Processing Method

Art Unit: 1763

Examiner: R. Kackar

PETITION FOR AN EXTENSION OF TIME

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 1, 2005

Sir:

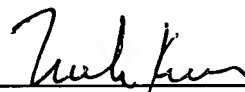
In the matter of the above-identified application, applicants hereby respectfully petition for an extension of time to permit the filing of a response within the second month subsequent to the expiration of the shortened statutory period set in the outstanding Office Action mailed June 2, 2005.

A payment in the amount of \$450.00 to cover the fee required for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 648.42568VX1).

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP


Melvin Kraus
Registration No. 22,466

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